

Resolution Chart for X-ray L & S Material: Au

JIMA RT RC-05

The most advanced Micro-technology realized precise Line & Space Microchart test piece with 16 different width (3 to 50 µm). Nowadays Microfocus X-Ray becomes major beam size, this is necessary item to adjust, setup, check and maintain your X-Ray system.

Microchart Pattern L & S width: 3 to 50 μm 300µm 6 300µm 8_mm (All line is same length) · Number of Au Slit is 3 lines and 2 space. · Width 3 to 10 µm: T Shape layout · Width 15 to 50 µm: I Shape layout · 16 sets of L&S layout in 2 x 2 mm Left drawing is image in size. Actual outer space around L&Ss are 3 mm each. 8_mm **Chip Cross Section** Protection Film (Aluminum Vapored) Au ($t >= 1.0 \mu m$) Material: Au Slit on 8 mm x 8 mm Si Base is fixed on Aluminum Housing Case (40 x 30 mm). Si Base



t=0.2mm

Price JP Yen: 160,000 (Shipping Charge excluded)

Relative Product:

Model RC-02B (Tungusten Slit, 0.4 to 15µm)



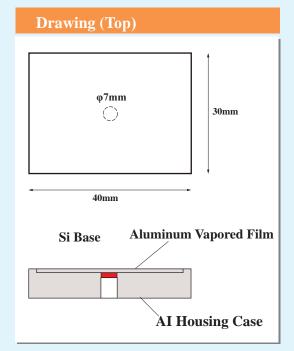
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Specification	
Size	40 x 30 mm, 3mm Thickness
Si Base	8 x 8 mm, 0.2mm Thickness
Absorption Material	Au, Thickness >= 1.0μm
Protection Film	Aluminum Vapored Film, 0.1mm Thickness
Number of Line	3 Lines (only 3~10μm: 6 lines)
Slit Width (Line and Space are Same width)	3, 4, 5, 6, 7, 8, 9, 10μm T Shape Layout 15, 20, 25, 30, 35, 40, 45, 50μm I Shape Layout
L/S Tolerance	± 10%
Operation Temparature	+10 deg C ~ +70 deg C



How to Order

Please send order to our office. Advanced Payment is required. After confirmation of payment, we will ship within 10 days. Note: Freight and Bank charge must be paid by customer.

Specification shall be changed without notice.

Contact



General Corporation

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